

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Application of Serial No.)
09/812,688, filed March 21, 2001, of:)
Masamitsu ITOH et al.) Group Art Unit: To be Assigned
Application No.: To be Assigned) Examiner: To be Assigned
Filed: Herewith)
For: PATTERN FORMATION)
MATERIAL, PATTERN)
FORMATION METHOD, AND)
EXPOSURE MASK)
FABRICATION METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above application, please amend this application
as follows:

Amendments to the Specification begins on page 2.

Amendments to the Claims are reflected in the listing of claims beginning on
page 3.

Remarks follow the amendment sections of this paper.